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Docket No. 1670.1020

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Koji Shigemura

Serial No. 10/717,571

Group Art Unit: 2879

Confirmation No. 9396

Filed: November 21, 2003

Examiner: Natalie K. Walford

For: DEPOSITION MASK FRAME ASSEMBLY, METHOD OF FABRICATING THE SAME,
AND METHOD OF FABRICATING ORGANIC ELECTROLUMINESCENT DEVICE
USING THE DEPOSITION MASK FRAME ASSEMBLY

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

This is responsive to the Office Action mailed October 18, 2005, having a shortened period for response set to expire on November 18, 2005. The following remarks are provided.

An Information Disclosure Statement was filed on November 21, 2003, and is respectfully requested that this Information Disclosure Statement be considered.

I. **Provisional Election of Claims Pursuant to 37 CFR § 1.142**

Applicant provisionally elects **claims 14-19 of Invention III** in response to the initial restriction requirement set forth in the Office Action.

II. **Applicant Traverses the Restriction Requirement**

The Examiner considers Invention I (drawn to a deposition mask frame assembly) to be related to both Invention II (drawn to a method of manufacturing a deposition mask frame assembly) and Invention III (drawn to a method of manufacturing an organic EL device using a deposition mask frame assembly) as process and apparatus for its practice, and considers Invention I to be distinct from both Invention II and Invention III pursuant to MPEP § 806.05(e)